

<b>Notice of References Cited</b>	Application/Control No. 10/653,302	Applicant(s)/Patent Under Reexamination JENG ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0097438 A1	05-2003	Bearden et al.	709/224
*	B	US-2004/0255154 A1	12-2004	Kwan et al.	713/201
*	C	US-2004/0255167 A1	12-2004	Knight, James Michael	713/201
*	D	US-2005/0015624 A1	01-2005	Ginter et al.	713/201
*	E	US-2005/0015623 A1	01-2005	Williams et al.	713/201
*	F	US-2005/0033989 A1	02-2005	Poletto et al.	713/201
*	G	US-2006/0080727 A1	04-2006	Hammons et al.	726/003
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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	O					
	P					
	Q					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date; Publisher, Edition or Volume, Pertinent Pages)
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	X	

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